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ISSN: 2349-5162 | ESTD Year: 2014 | Monthly Issue



JOURNAL OF EMERGING TECHNOLOGIES AND INNOVATIVE RESEARCH (JETIR)

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Ref No: JETIR / Vol 5 / Issue 5 / 631

Confirmation Letter

To,

Waghoo Parvez

Published in : Volume 5 | Issue 5 | 2018-05-01



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Published in : Volume 5 | Issue 5 | 2018-05-01

Publication Date: 2018-05-01 Page No : 173-177

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Thank you very much for publishing your article in JETIR. We would appreciate if you continue your support and keep sharing your knowledge by writing for our journal JETIR.



















International Journal of Emerging Technologies and Innovative Research (ISSN: 2349-5162)

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